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Total number of printed pages – 2

B. Tech
PEEL 5301

Fifth Semester Back Examination – 2014
SENSORS AND TRANSDUCERS
BRANCH(S) : EEE, ELECTRICAL

QUESTION CODE : L 275

Full Marks – 70

Time : 3 Hours

Answer Question No. 1 which is compulsory and any **five** from the rest.

The figures in the right-hand margin indicate marks.

1. Answer the following questions : 2 × 10
- Justify the statement : "Tolerance is the statistical variations amongst a batch of similar elements".
 - Write one example of "direct equation" and "inverse equation" for a thermocouple with reference junction at 0°C.
 - Draw the circuit diagram of a Kelvin Double Bridge and write the equation at balance.
 - Draw the time response curve of a 1st order system when subjected to
 - unit step input and
 - unit ramp input.
 - What do you mean by reference junction compensation of a thermocouple ?
 - The output voltage of a LVDT is 1.5 V at maximum displacement. At a load of 0.5 MΩ, the deviation from linearity is maximum, and it is ±0.003 V from a straight line through origin. Find the linearity at the given load.
 - Write the formula for the resistance R of a thermistor as a function of absolute temperature T, coefficient β, reference temperature T₀ and reference resistance R₀.
 - What are the advantages of an Instrumentation amplifier over practical DC operational amplifier ?
 - What are the advantages of using a Differential Push-pull arrangement in capacitive and inductive sensors ? Also draw the circuit diagram of a variable plate capacitive sensor and variable reluctance type sensor in differential Push pull arrangements.
 - A lowpass filter is specified to have A_{max} = 1dB and A_{min} = 10dB. It is found that these specifications can be met with a single-time-constant RC circuit having a time constant of 1 sec and a dc transmission of unity. What must be the ω_p and ω_s of this filter ?
2. (a) Give an example of a second order system and derive its transfer function. Also, find the step input response of the system. 5

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- (b) Define the terms : 5
- (i) Time constant and
- (ii) Damping ratio, used in describing dynamic characteristics of measurement system.
3. (a) Describe the Thevenin's equivalent circuit of a thermocouple temperature measurement system. Write the expression of the measured temperature. 5
- (b) Explain the operating principles of pressure measurement using a diaphragm. 5
4. A variable reluctance sensor, consist of a core, variable air-gap, and an armature. The core is a steel rod of diameter 1 cm, relative permeability 100, bent to form a semi-circle of diameter 4 cm, a coil of 500 turns is wound onto the core. The armature is a steel plate of thickness 0.5 cm, calculate the inductance of sensor for air gap of 1 mm. Given: the relative permeability of air = 1.0 and the permeability of free space = $4\pi \times 10^{-7}$. 10
5. (a) Explain the operating Principle of an LVDT and function of phase sensitive demodulator circuit associate with LVDT. 5
- (b) Define Gauge factor of a strain gauge and derive an expression for it. Derive the output voltage for four element strain gauge bridge. 5
6. (a) Draw the circuit diagram and list the important characteristics of an instrumentation amplifier. Derive the expression of the output voltage. Explain how the GAIN is adjusted. 5
- (b) Derive the transfer function of the circuit shown in Figure 1 below (for an ideal op-amp) and show that it can be written in the form 5

$$\frac{V_0}{V_i} = \frac{-\frac{R_2}{R_1}}{\left[1 + \frac{\omega_1}{j\omega}\right] \left[1 + j\left(\frac{\omega_1}{\omega_2}\right)\right]}$$

$$\text{where } \omega_1 = \frac{1}{C_1 R_1} \text{ and } \omega_2 = \frac{1}{C_2 R_2}.$$

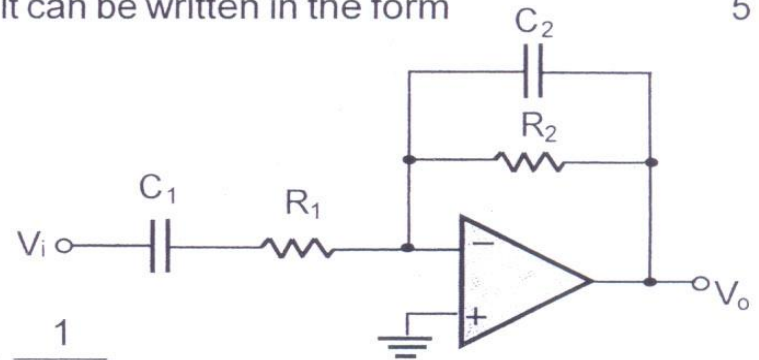


Figure 1

7. (a) With the help of neat schematic diagram describe the functionalities of a phase sensitive demodulator and its applications in instrumentation. 5
- (b) Discuss dynamic errors in instrumentation systems. 5
8. Write short notes on any **two** of the following : 5 × 2
- (a) Electromagnetic sensors
- (b) Semiconductor strain gauge
- (c) IC temperature sensor
- (d) AC carrier systems.